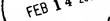




**SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT BY
APPLICANT PTO-1449**

 <p>SUPPLEMENTARY INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449</p>	<p>Docket No. 52433/860</p>	<p>Application No. 10/591,919</p>	
	<p>Applicant(s) TANIGUCHI et al.</p>	<p>Examiner Michael E. Lavilla</p>	
	<p>Filing Date September 6, 2006</p>	<p>Confirmation No. 5382</p>	<p>Art Unit 1794</p>

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE'

FOREIGN PATENT DOCUMENTS

[illegible]

EXAMINER	/Rebecca Lee/	DATE CONSIDERED	12/22/2009
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			